

## Introduction

### 1 – Batch Reactor (BSTR)

### 2 – Continuous Reactor (CSTR)

#### 2.1 – Mass balance to the cell concentration

#### 2.2 – Mass balance to the substrate

#### 2.3 - Relationship between substrate concentration and cell concentration with dilution rate

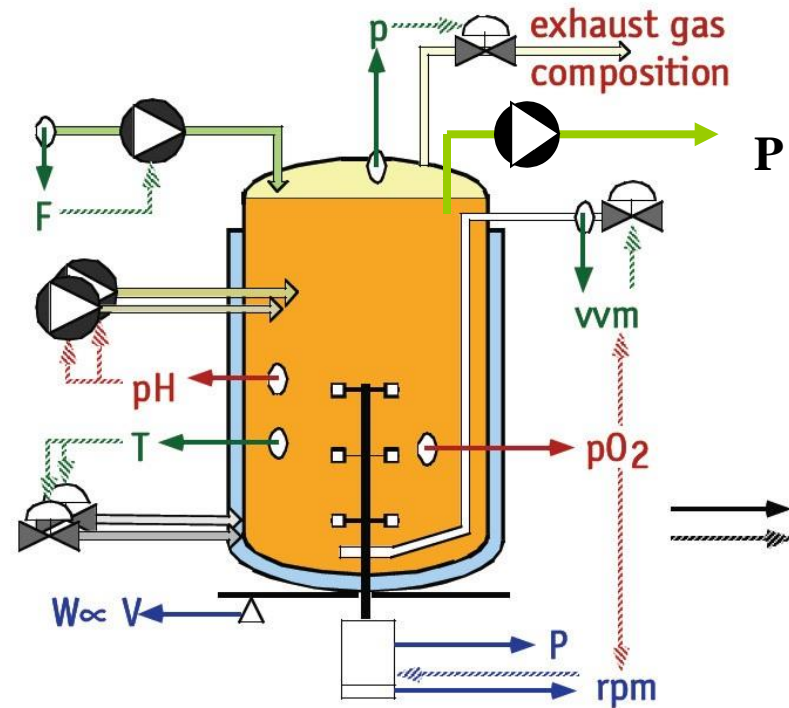
#### 2.4 - Cell Productivity

#### 2.5 - Effect of the maintenance coefficient

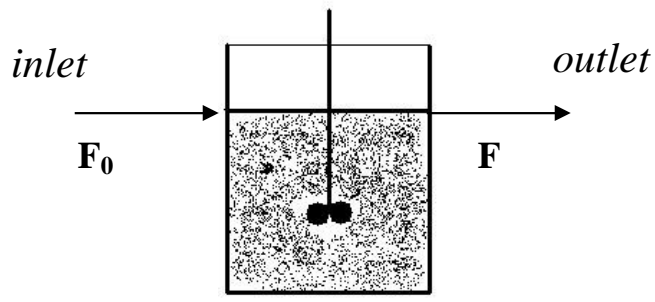
#### 2.6 - Product production

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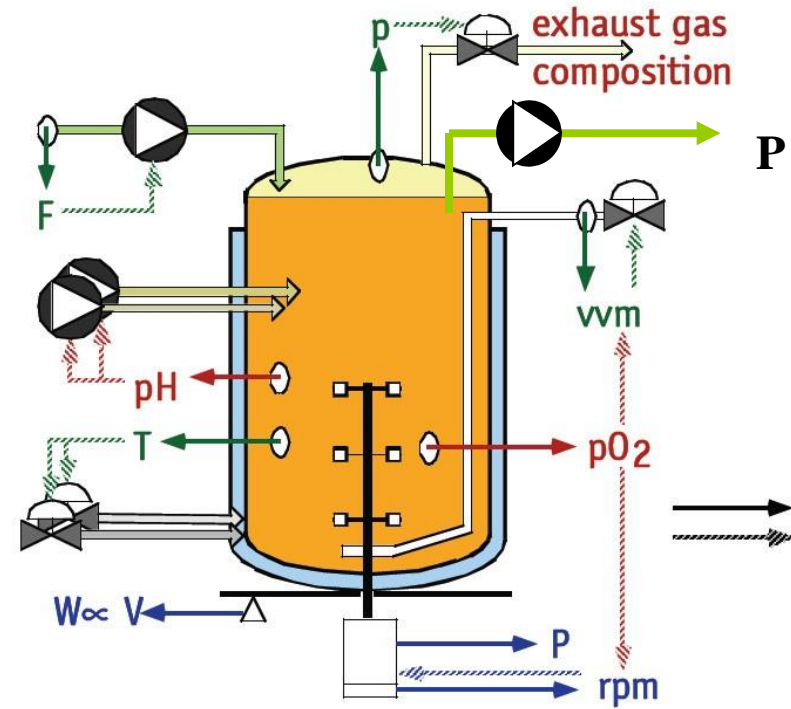
### Continuous Stirred Tank Reactor - CSTR



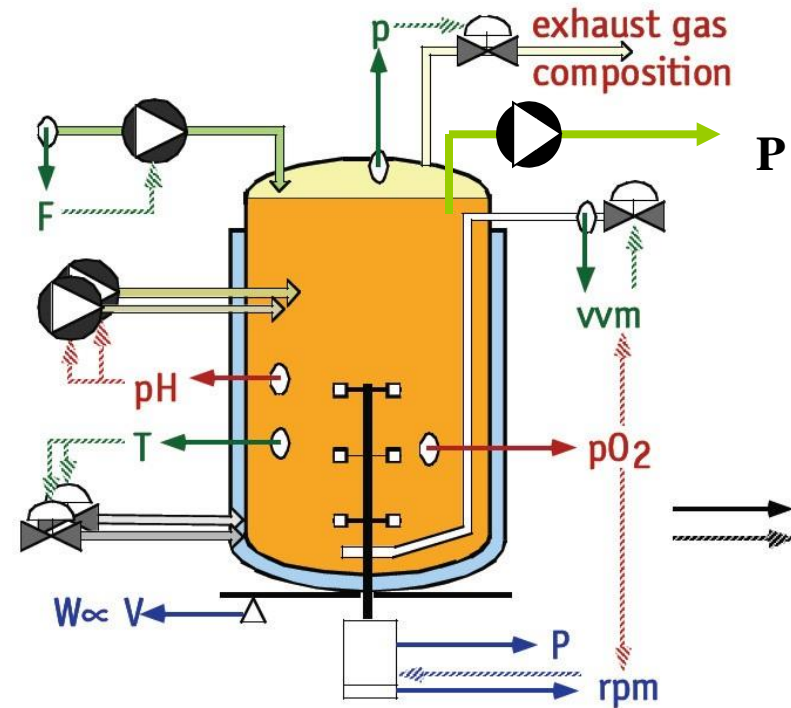
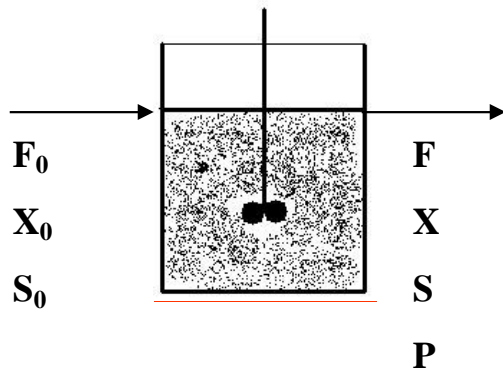
### Continuous Stirred Tank Reactor - CSTR



$F$  – flow rate (l/h)



### Continuous Stirred Tank Reactor - CSTR



$F$  – flow rate (l/h)  
 $x$  – cell concentration (gX/l)  
 $S$  – substrate concentration (gS/l)  
 $P$  – product concentration (gP/l)

### 2.1 – Mass balance to the cell concentration

$$\frac{dx}{dt} = \frac{F_0}{V} x_0 - \frac{F}{V} x + \mu x - k_d x$$

$F_0$  – inlet flow rate (l/h)

$V$  - volume of the reactor (l)

$k_d$  – specific cell death rate ( $\text{h}^{-1}$ )

$x_0$  - inlet cell concentration (gX/l)

with  $F_0 = F$

### 2.1 – Mass balance to the cell concentration

$$\frac{dx}{dt} = \frac{F_0}{V} x_0 - \frac{F}{V} x + \mu x - k_d x$$

Cells entering the reactor

Cells exiting the reactor

Cell growth

Cell death

### 2.1 – Mass balance to the cell concentration

$$\frac{dx}{dt} = \cancel{\frac{F_0}{V} x_0} - \frac{F}{V} x + \mu x - \cancel{k_d x}$$

$F_0$  – inlet flow rate (l/h)

$V$  - volume of the reactor (l)

$k_d$  – specific cell death rate ( $\text{h}^{-1}$ )

$x_0$  - inlet cell concentration (gX/l)

with  $F_0 = F$

In most fermentations ( $x_0 = 0$ ) and ( $\mu \gg k_d$ ):

$$\frac{dx}{dt} = - \frac{F}{V} x + \mu x$$

$$\frac{F}{V} = D = \frac{1}{TRH}$$

$D$  - dilution rate ( $\text{h}^{-1}$ )

$TRH$  - hydraulic retention time (h)

### 2.1 – Mass balance to the cell concentration

$$\frac{dx}{dt} = -\frac{F}{V}x + \mu x \quad \longrightarrow \quad \frac{dx}{dt} = \mu x - Dx$$

$$\frac{F}{V} = D$$



### 2.1 – Mass balance to the cell concentration

$$\frac{dx}{dt} = -\frac{F}{V}x + \mu x \quad \longrightarrow \quad \frac{dx}{dt} = \mu x - Dx$$

In steady state:  $\frac{dx}{dt} = 0$

$$Dx = \mu x \quad \longrightarrow \quad \mu = D$$

**In steady state, without cell death and sterile feeding:**

$$\mu = D$$

### 2.2 – Mass balance to the substrate

$$\frac{dS}{dt} = \frac{F S_0}{V} - \frac{F S}{V} - \frac{1}{Y_{x/s}} \mu x - m x$$

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$$\frac{dS}{dt} = \frac{F S_0}{V} - \frac{F S}{V} - \frac{1}{Y_{x/s}} \mu x - m x$$

Substrate entering the reactor

Substrate exiting the reactor

Substrate used for cell growth

Substrate used for maintenance

### 2.2 – Mass balance to the substrate

$$\frac{dS}{dt} = \frac{F S_0}{V} - \frac{F S}{V} - \frac{1}{Y_{x/s}} \mu x - m x$$

$$\frac{F}{V} = D$$

$$\frac{dS}{dt} = D S_0 - D S - \frac{1}{Y_{x/s}} \mu x - \cancel{m x}$$

if  $m$  is negligible ( $\cancel{m x} \ll \mu x$ ):

$$\frac{dS}{dt} = D (S_0 - S) - \frac{1}{Y_{x/s}} \mu x$$

### 2.2 – Mass balance to the substrate

In steady state

$$\frac{dS}{dt} = 0$$

$$D (S_0 - S) = \frac{1}{Y_{x/s}} \mu x$$

$$\mu = D$$

$$D (S_0 - S) = \frac{1}{Y_{x/s}} D x$$

$$Y_{x/s} (S_0 - S) = x$$

### 2.3 – Relationship between substrate concentration and cell concentration with dilution rate

$$\mu = \frac{\mu_{\max} S}{K_s + S}$$

In a continuous reactor under steady state

$$D = \frac{\mu_{\max} S}{K_s + S}$$

Rearranging for S

$$S = \frac{K_s D}{\mu_{\max} - D}$$

### 2.3 – Relationship between substrate concentration and cell concentration with dilution rate

$$S = \frac{K_s D}{\mu_{\max} - D}$$

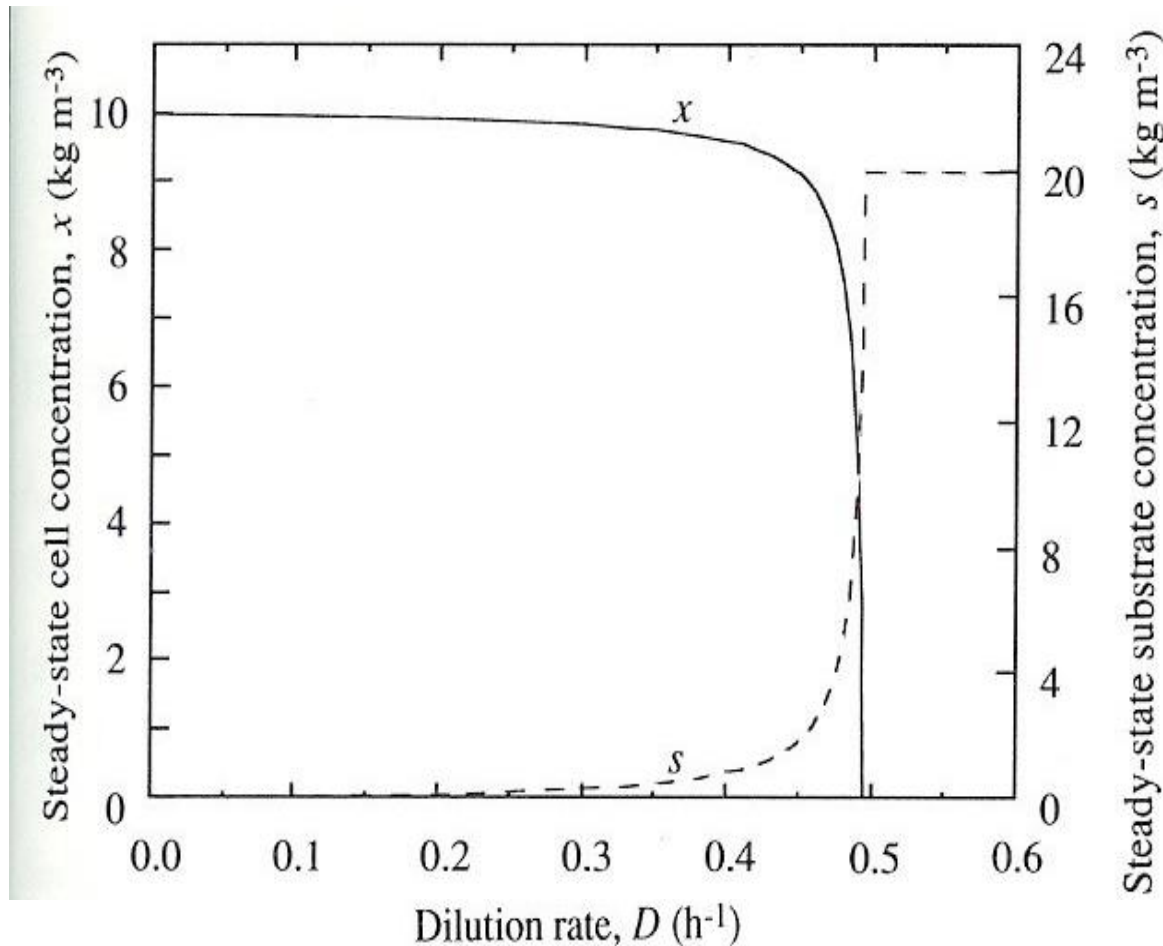
$$Y_{x/s} (S_0 - S) = x$$

$$x = Y_{x/s} \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

when  $D \rightarrow 0$   
 $S \rightarrow 0$

$$x = Y_{x/s} S_0$$

### 2.3 – Relationship between substrate concentration and cell concentration with dilution rate



For high dilution rates:

- $X$  decreases sharply
- $S$  is not consumed  
→  $S_0$



### 2.3 – Relationship between substrate concentration and cell concentration with dilution rate

The value at which  $x=0$  and  $D \sim \mu_{\max}$  is named the critical washout rate  $D_c$

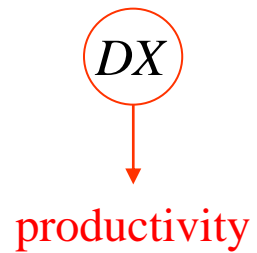
At this  $D$  value we have an “washout” of the reactor

$$D_c = \frac{\mu_{\max} S_0}{K_s + S_0}$$

If  $S_0 \gg K_s$  then  $D_c = \mu_{\max}$

This point is very sensitive: a small variation of  $D$  gives a large variation of  $X$  or  $S$

### 2.4 – Cell Productivity



### 2.4 – Cell Productivity

$$DX = Y_{x/s} D \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

Maximum productivity is obtained for:

$$\frac{dDx}{dD} = 0$$

Then:

$$D_{\max} = \mu_{\max} \left[ 1 - \left( \frac{K_s}{K_s + S_0} \right)^{1/2} \right]$$

When  $S_0 > K_s \rightarrow \mu = \mu_{\max}$ , near washout.

### 2.4 – Cell Productivity

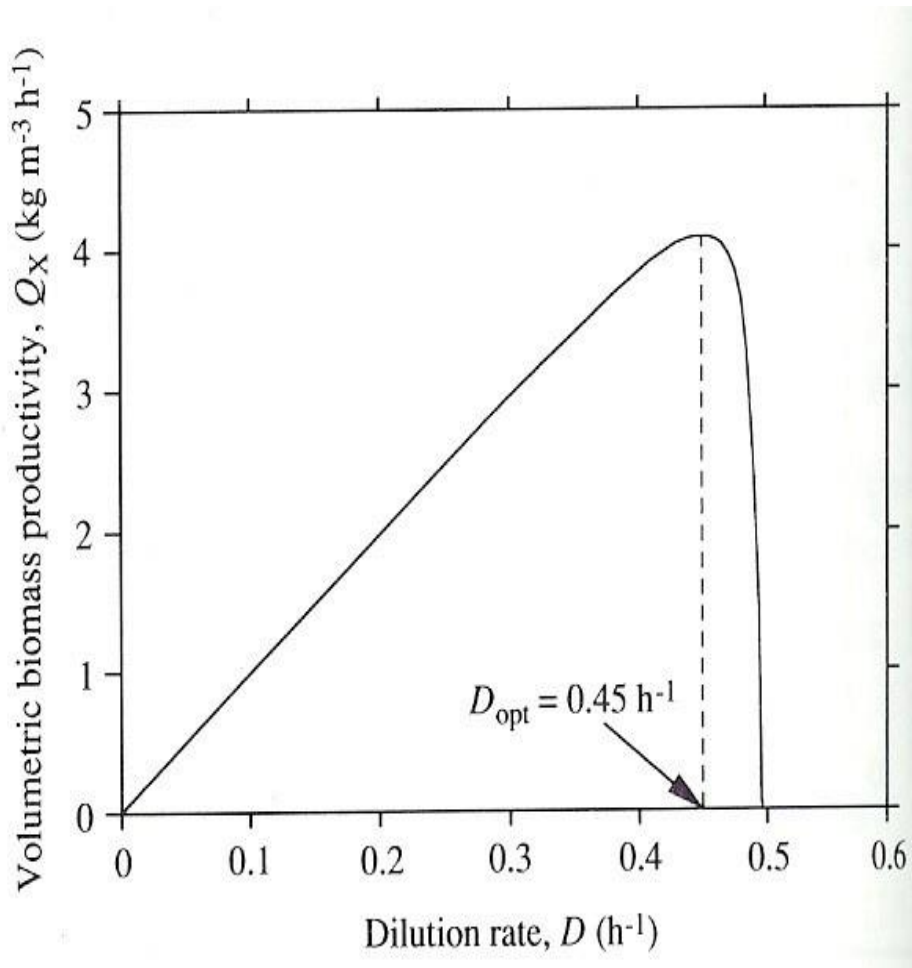
The cell concentration corresponding to the point of maximum productivity is given by:

$$X_m = Y_{x/s} (S_0 + K_s - [K_s (S_0 + K_s)]^{1/2})$$

For  $S_0 \gg K_s$

$$D_{\max} X_m = D_{\max} Y_{x/s} S_0$$

### 2.4 – Cell Productivity



The productivity:

- Increases with the dilution rate until  $D_{\text{opt}}$
- Decreases sharply after  $D_{\text{opt}}$   
→ zero

### 2.5 – Effect of the maintenance coefficient

$$\frac{ds}{dt} = D(S_0 - S) - \frac{1}{Y'_{x/s}} \mu x - mx$$

Substrate entering  
the reactor

Substrate exiting  
the reactor

Substrate used for  
cell growth

Substrate used for  
maintenance

### 2.5 – Effect of the maintenance coefficient

$$\frac{ds}{dt} = D(S_0 - S) - \frac{1}{Y'_{x/s}} \mu x - mx$$

In steady state:  $\frac{ds}{dt} = 0 \Rightarrow D(S_0 - S) = \frac{1}{Y'_{x/s}} Dx + mx$

Rearranging:  $x = \frac{D(S_0 - S)}{\frac{1}{Y'_{x/s}} D + m}$  or  $x = \frac{S_0 - S}{\frac{1}{Y'_{x/s}} + \frac{m}{D}}$

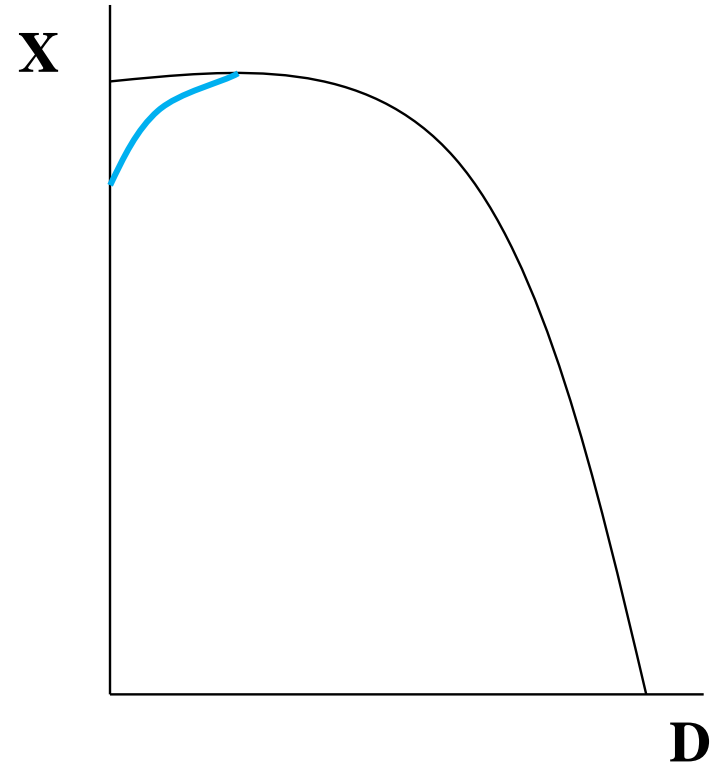
### 2.5 – Effect of the maintenance coefficient

$$X = \frac{S_0 - S}{\frac{1}{Y'_{x/s}} + \frac{m}{D}}$$

For low D values: X decreases due to m

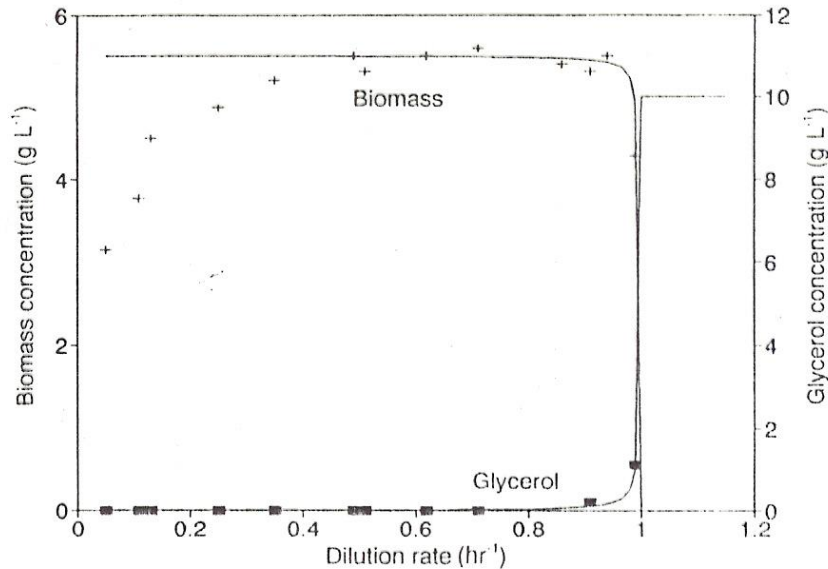
For high D values: X does not depend on m

$$X = \frac{S_0 - S}{\frac{1}{Y'_{x/s}} + \frac{m}{D}} \longrightarrow X = \frac{S_0 - S}{\frac{1}{Y'_{x/s}}}$$



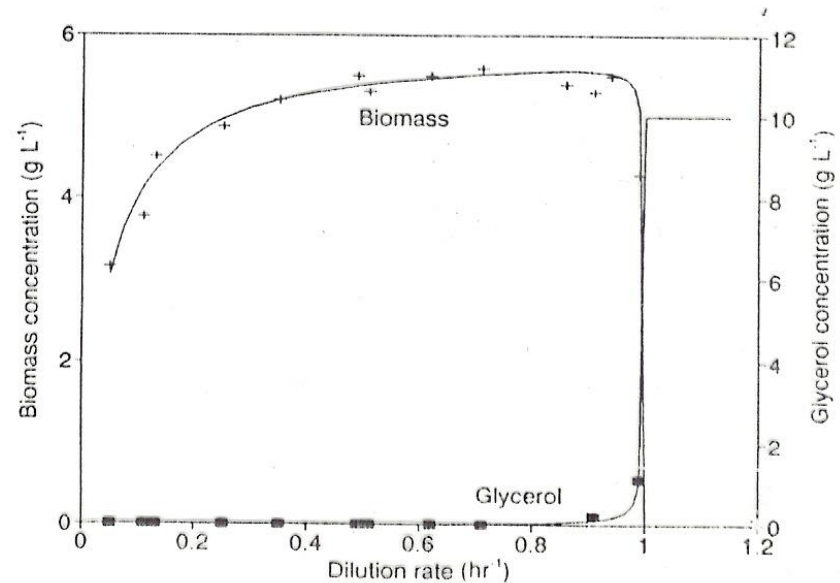


### 2.5 – Effect of the maintenance coefficient



Monod model applied to CSTR

$$x = Y_{x/s} \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

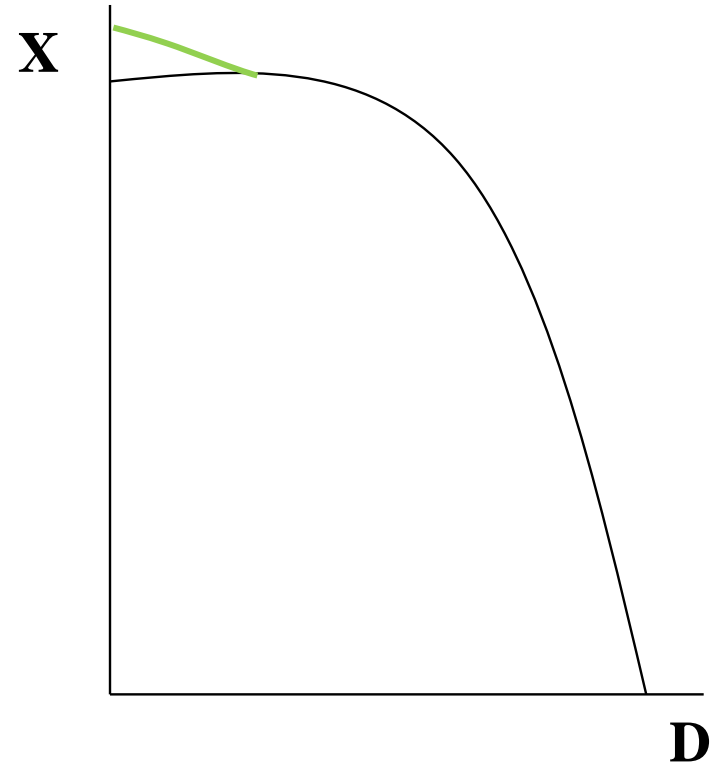


Monod model applied to CSTR  
considering the cell maintenance

$$x = \frac{D(S_0 - S)}{\frac{1}{Y'_{x/s}} D + m}$$

### 2.5 – Effect of the maintenance coefficient

increase in biomass weight due to the  
production of intracellular reserves



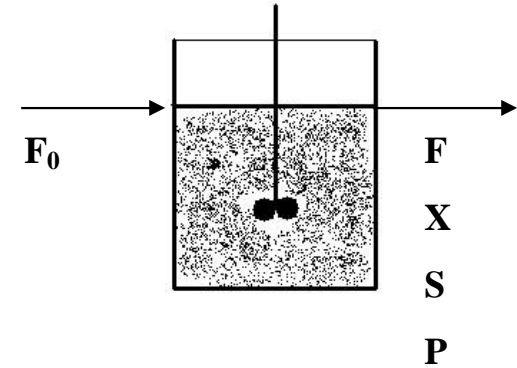
### 2.6 – Product production

#### 2.6.1- Product associated to growth

$$\frac{dP}{dt} = -DP + Y_{p/x}\mu X$$

Product exiting the reactor

Product formed



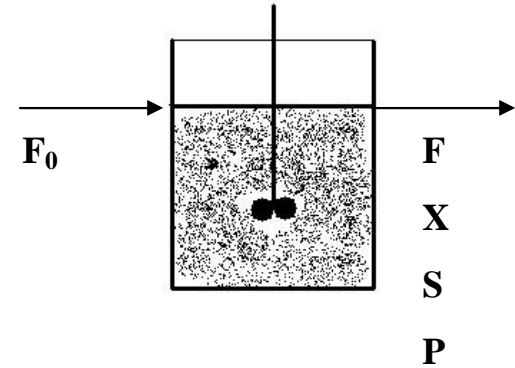
### 2.6 – Product production

#### 2.6.1- Product associated to growth

$$\frac{dP}{dt} = -DP + Y_{p/x}\mu X$$

At steady-state

$$\frac{dP}{dt} = 0$$



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#### 2.6.1- Product associated to growth

$$\frac{dP}{dt} = -DP + Y_{p/x}\mu X$$

At steady-state

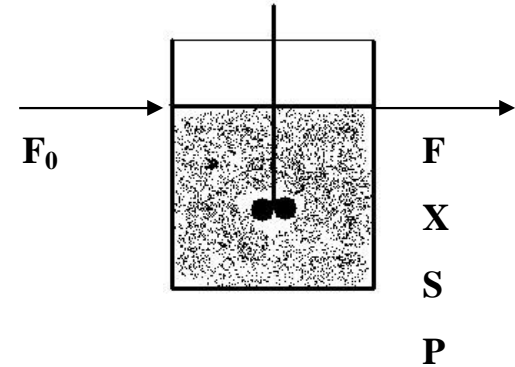
$$\frac{dP}{dt} = 0 \Rightarrow DP = Y_{p/x}\mu X$$

$$\Leftrightarrow \frac{D \cdot P}{X} = Y_{p/x} \mu$$

$$\Leftrightarrow V_p = Y_{p/x} \mu$$

(Volumetric productivity (gP/l.h))

(Specific productivity (gP/gX.h))



### 2.6 – Product production

#### 2.6.1- Product associated to growth

$$\left. \begin{array}{l} X = Y_{x/s}(S_0 - S) \\ S = \frac{K_s D}{\mu_{\max} - D} \end{array} \right\} X = Y_{x/s} \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

$$DP = Y_{p/x} \mu X \Leftrightarrow DP = Y_{p/x} D X$$

At steady-state

$$D = \mu$$

### 2.6 – Product production

#### 2.6.1- Product associated to growth

$$\left. \begin{array}{l} X = Y_{x/s}(S_0 - S) \\ S = \frac{K_s D}{\mu_{\max} - D} \end{array} \right\} X = Y_{x/s} \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

$$DP = Y_{p/x}\mu X \Leftrightarrow DP = Y_{p/x}DX$$

$$\Leftrightarrow DP = Y_{p/x}D Y_{x/s} \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

### 2.6 – Product production

#### 2.6.1- Product associated to growth

$$DP = Y_{p/x} D Y_{x/s} \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$
$$\Leftrightarrow DP = Y_{p/s} D \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

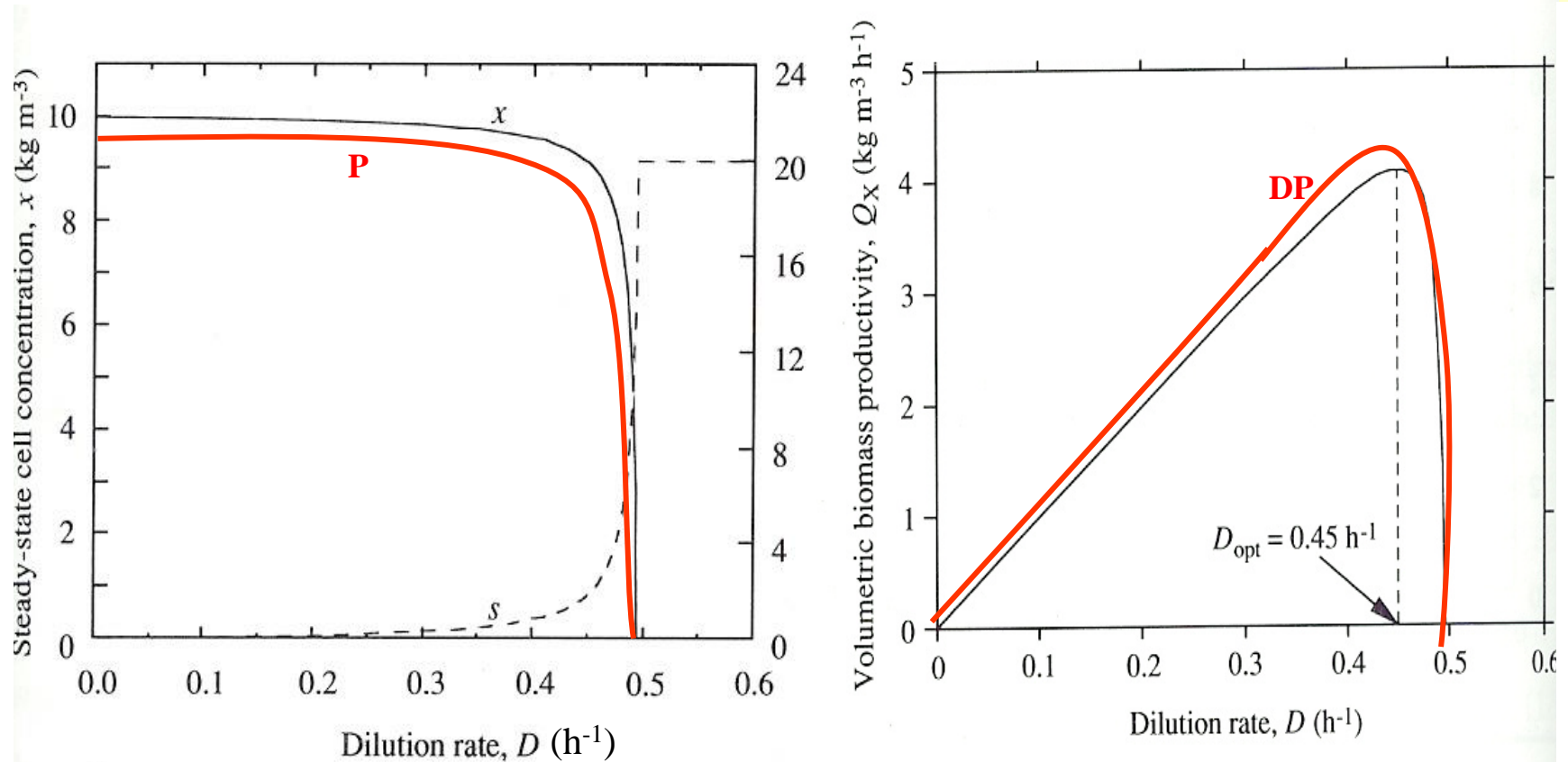
$Y_{p/x} Y_{x/s} = Y_{p/s}$

Product concentration (P) and volumetric productivity (DP) follow the same trend of X and DX as a function of D (see figure below, lines in red).



### 2.6 – Product production

#### 2.6.1- Product associated to growth



### 2.6 – Product production

#### 2.6.1- Product associated to growth

$$DP = Y_{p/s} D \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right) \Leftrightarrow P = Y_{p/s} \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

### 2.6 – Product production

#### 2.6.1- Product associated to growth

$$DP = Y_{p/s} D \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right) \Leftrightarrow P = Y_{p/s} \left( S_0 - \frac{K_s D}{\mu_{\max} - D} \right)$$

The maximum productivity is obtained for  $D_{\max}$

At this point the product concentration is:

$$D_{\max} = \mu_{\max} \left[ 1 - \left( \frac{K_s}{K_s + S_0} \right)^{1/2} \right]$$

$$P_m = Y_{p/s} (S_0 + K_s - (K_s(S_0 + K_s))^{1/2})$$

### 2.6 – Product production

#### 2.6.1- Product partially associated to growth

Mass balance to the substrate:

$$\frac{dS}{dt} = DS_0 - DS - \frac{1}{Y'_{x/s}} \mu X - \frac{1}{Y'_{p/s}} r_p - mX$$

### 2.6 – Product production

#### 2.6.1- Product partially associated to growth

Mass balance to the substrate:

$$\frac{dS}{dt} = DS_0 - DS - \frac{1}{Y'_{x/s}} \mu X - \frac{1}{Y'_{p/s}} r_p - mX$$

The diagram shows the mass balance equation for substrate in a continuous reactor. The equation is  $\frac{dS}{dt} = DS_0 - DS - \frac{1}{Y'_{x/s}} \mu X - \frac{1}{Y'_{p/s}} r_p - mX$ . Each term is enclosed in a dashed red oval, and a red dashed arrow points from each oval to a descriptive text label below it:

- $DS_0$ : Substrate entering the reactor
- $DS$ : Substrate exiting the reactor
- $\frac{1}{Y'_{x/s}} \mu X$ : Substrate spent for cell growth
- $\frac{1}{Y'_{p/s}} r_p$ : Substrate spent for product formation
- $mX$ : Substrate spent for maintenance

### 2.6 – Product production

#### 2.6.1- Product partially associated to growth

Mass balance to the substrate:

$$\frac{dS}{dt} = DS_0 - DS - \frac{1}{Y'_{x/s}} \mu X - \frac{1}{Y'_{p/s}} r_p - mX$$

$$V_p = \frac{r_p}{X} \Leftrightarrow r_p = V_p X$$

$$\frac{dS}{dt} = DS_0 - DS - \frac{1}{Y'_{x/s}} \mu X - \frac{1}{Y'_{p/s}} V_p X - mX$$

$$\Leftrightarrow \frac{dS}{dt} = D(S_0 - S) - \left( \frac{1}{Y'_{x/s}} \mu + \frac{1}{Y'_{p/s}} V_p + m \right) X$$

### 2.6 – Product production

#### 2.6.1- Product partially associated to growth

$$\frac{dS}{dt} = D(S_0 - S) - \left( \frac{1}{Y'_{x/s}} \mu + \frac{1}{Y'_{p/s}} V_p + m \right) X$$

At steady-state

$$D(S_0 - S) = \left( \frac{1}{Y'_{x/s}} D + \frac{1}{Y'_{p/s}} V_p + m \right) X$$

$$D = \mu$$

$$\frac{dS}{dt} = 0$$

$$\Leftrightarrow X = \frac{D(S_0 - S)}{\frac{D}{Y'_{x/s}} + \frac{1}{Y'_{p/s}} V_p + m}$$


### 2.6 – Product production

#### 2.6.1- Product partially associated to growth

$$\frac{dP}{dt} = -DP + V_p X$$

$$\Leftrightarrow \frac{dP}{dt} = -DP + (Y'_{p/x} \mu + m_p) X$$

$$\Leftrightarrow DP = (Y'_{p/x} \mu + m_p) X$$


$$V_p = Y'_{p/x} \mu + m_p$$

At steady-state

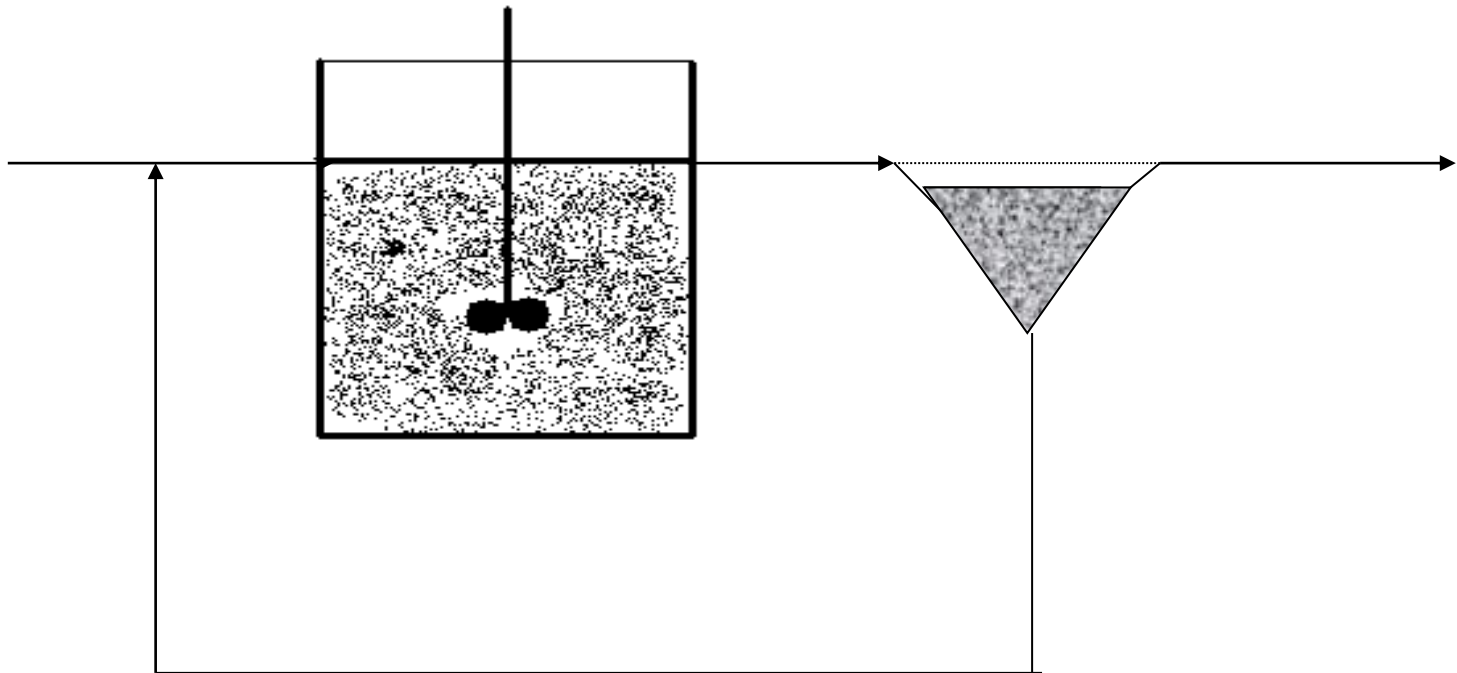
$$D = \mu$$

$$\frac{dS}{dt} = 0$$



### 2.7 – Cell recirculation reactors

With a decanter



### 2.7 – Cell recirculation reactors

#### Membrane bioreactors

##### Type of membranes

- Dense
- Microporous

##### Configurations

- External circuit membrane
- Submerged membrane

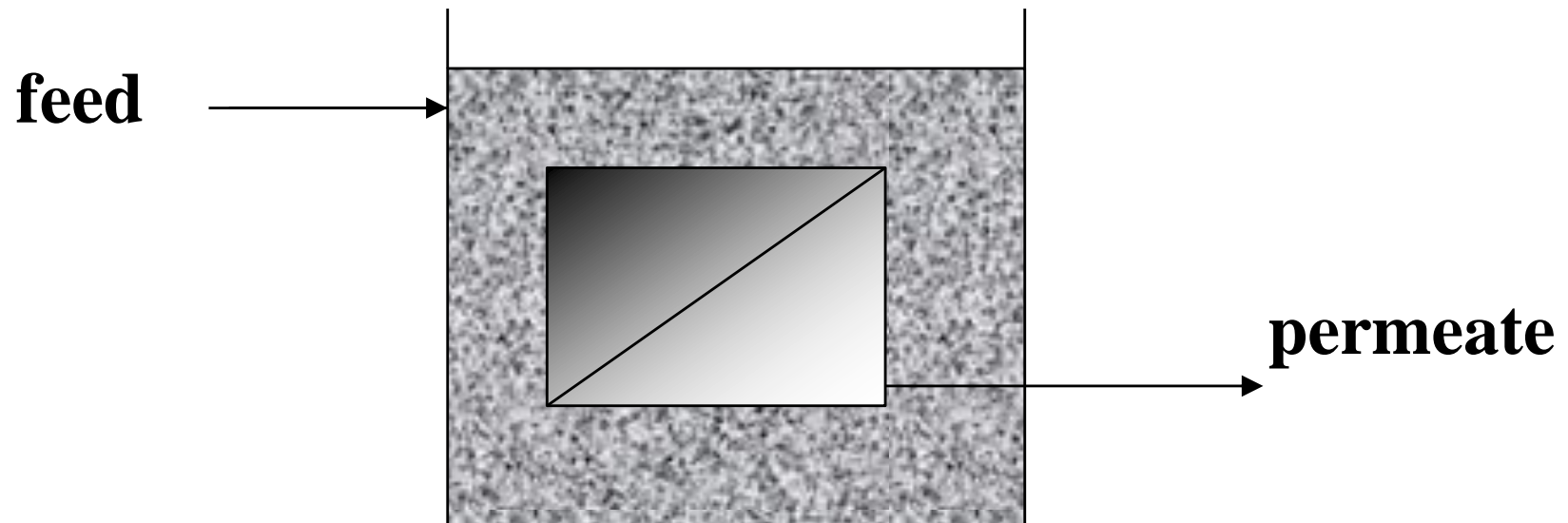
##### Applications

- Chemicals production
- Treatment of gaseous or liquid effluents

### 2.7 – Cell recirculation reactors

#### Membrane bioreactors

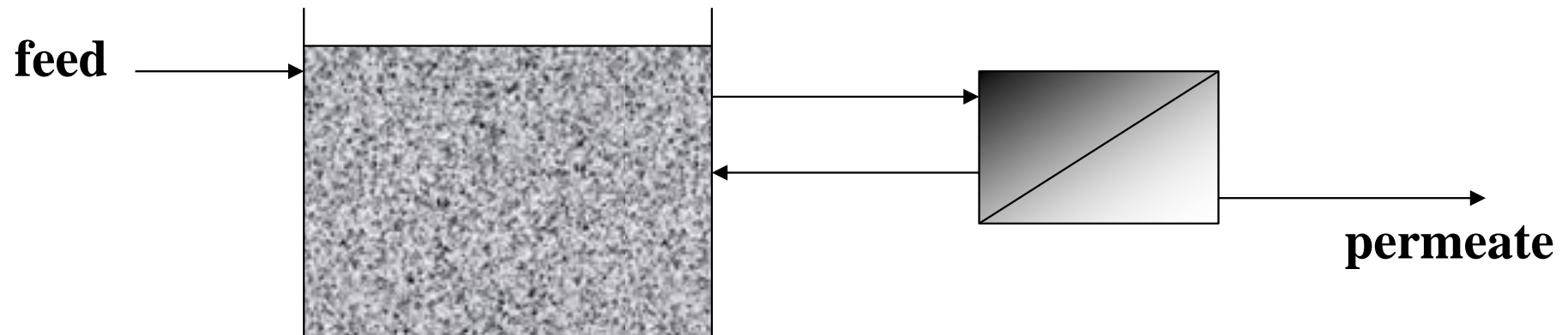
##### Submerged membrane bioreactor



### 2.7 – Cell recirculation reactors

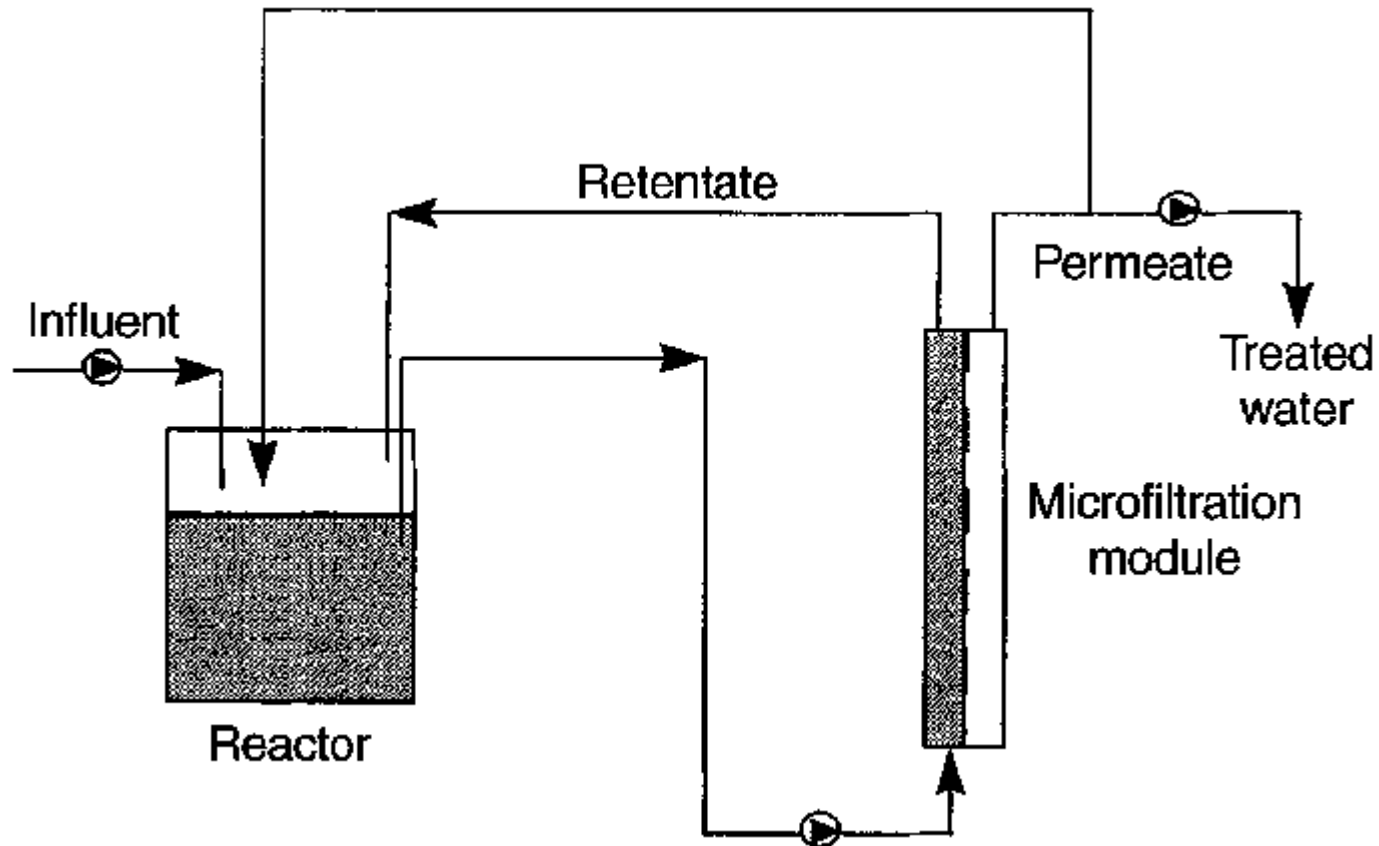
#### Membrane bioreactors

#### Membrane bioreactor with cell recirculation



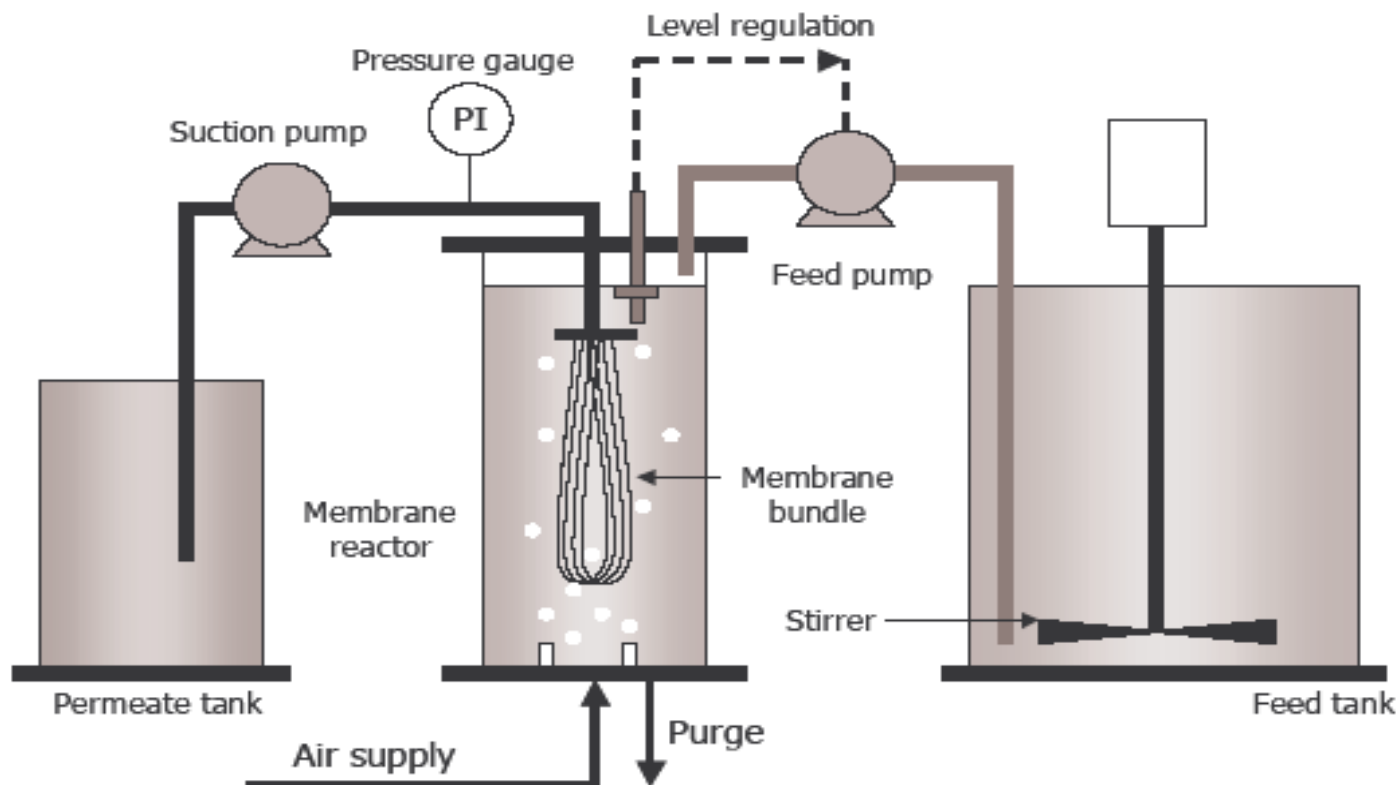
### 2.7 – Cell recirculation reactors

#### Membrane bioreactors

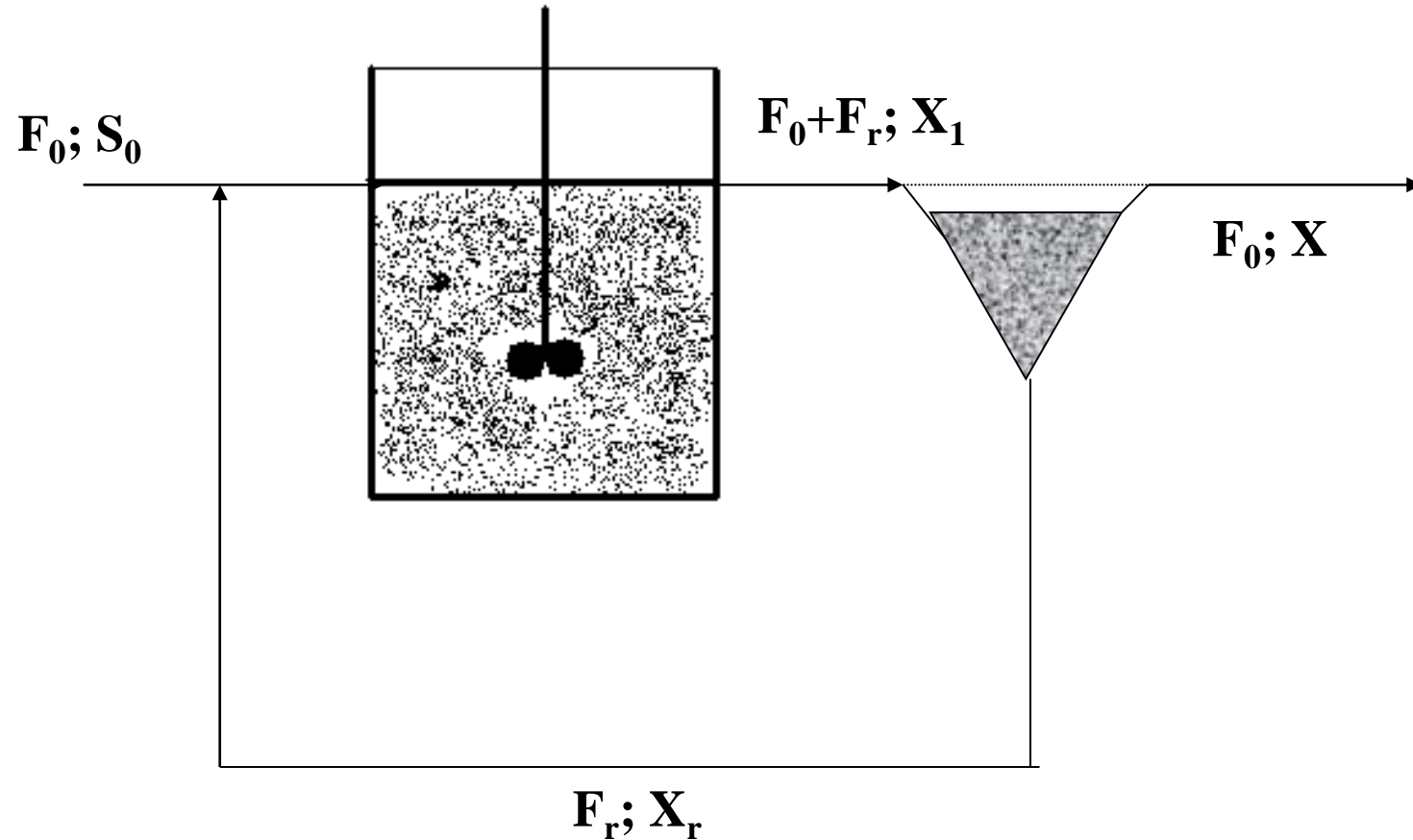


### 2.7 – Cell recirculation reactors

#### Submerged membrane bioreactors



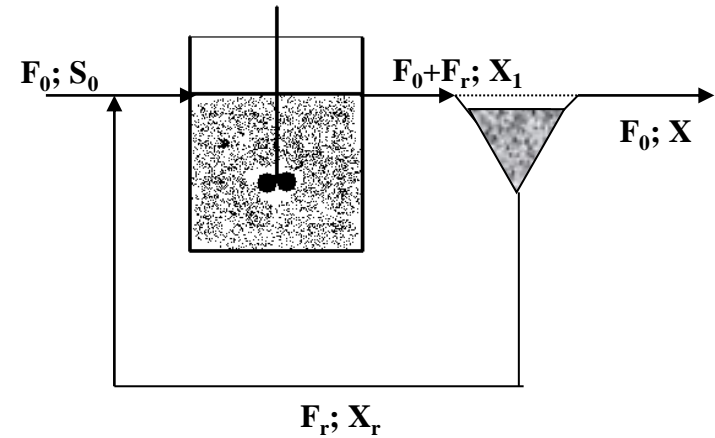
### 2.7 – Cell recirculation reactors



### 2.7 – Cell recirculation reactors

Balance to the biomass:

$$\frac{dX}{dt} = \frac{F_r}{V} X_r - \frac{F_0 + F_r}{V} X_1 + \mu X_1$$





### 2.7 – Cell recirculation reactors

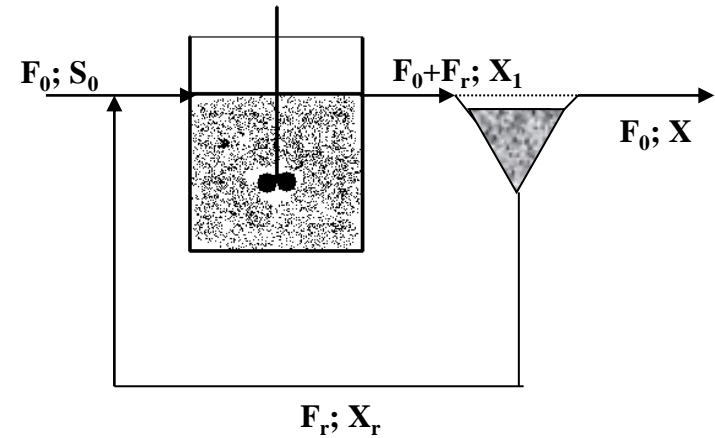
Balance to the biomass:

$$\frac{dX}{dt} = \frac{F_r}{V} X_r - \frac{F_0 + F_r}{V} X_1 + \mu X_1$$

Biomass entering the reactor

Biomass exiting the reactor

Cell growth



### 2.7 – Cell recirculation reactors

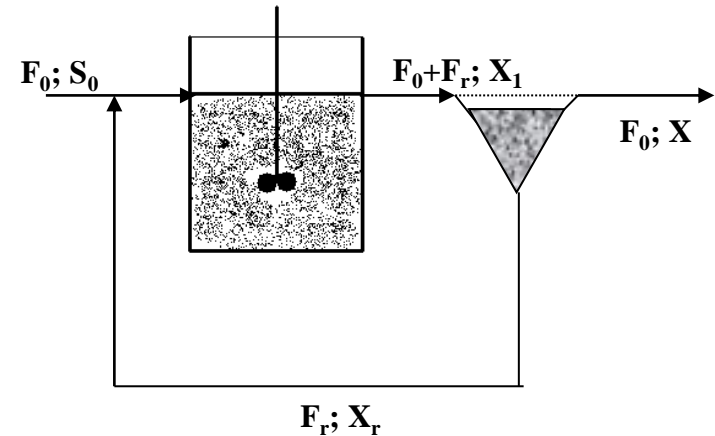
Balance to the biomass:

$$\frac{dX}{dt} = \frac{F_r}{V} X_r - \frac{F_0 + F_r}{V} X_1 + \mu X_1$$

At steady-state  $\frac{dX}{dt} = 0$

$$0 = \frac{F_r}{V} X_r - \frac{F_0 + F_r}{V} X_1 + \mu X_1$$

$$\Leftrightarrow 0 = F_r X_r - (F_0 + F_r) X_1 + \mu X_1 V$$



Multiplying by V



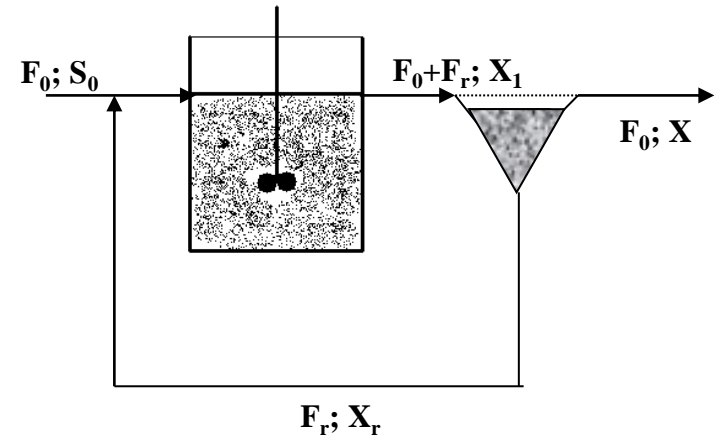
### 2.7 – Cell recirculation reactors

Balance to the biomass:

$$0 = F_r X_r - (F_0 + F_r) X_1 + \mu X_1 V$$

If  $a = \frac{F_r}{F_0}$      $b = \frac{x_r}{x_1}$      $D = \frac{F_0}{V}$

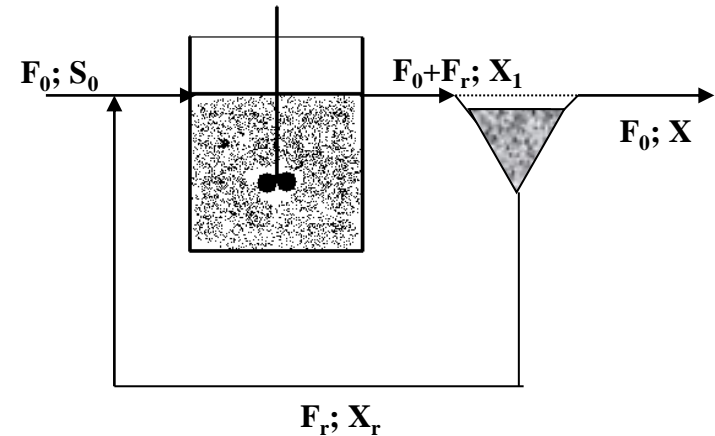
Then:  $D = \frac{\mu}{1 - a(b - 1)}$



### 2.7 – Cell recirculation reactors

Balance to the substrate:

$$\frac{dS}{dt} = D(S_0 - S) - \frac{\mu X_1}{Y_{x/s}} = 0$$



$$a = \frac{F_r}{F_0} \quad b = \frac{x_r}{x_1} \quad D = \frac{F_0}{V} \quad \longrightarrow \quad \mu x_1 = \frac{\mu Y_{x/s} (S_0 - S)}{1 - a(b - 1)}$$

The rate of biomass production increases with a factor :  $[1 - a(b - 1)]^{-1}$

### 2.7 – Cell recirculation reactors

#### Comparison of reactors with and without cell recirculation

